

Instrumentation for a low-energy beam

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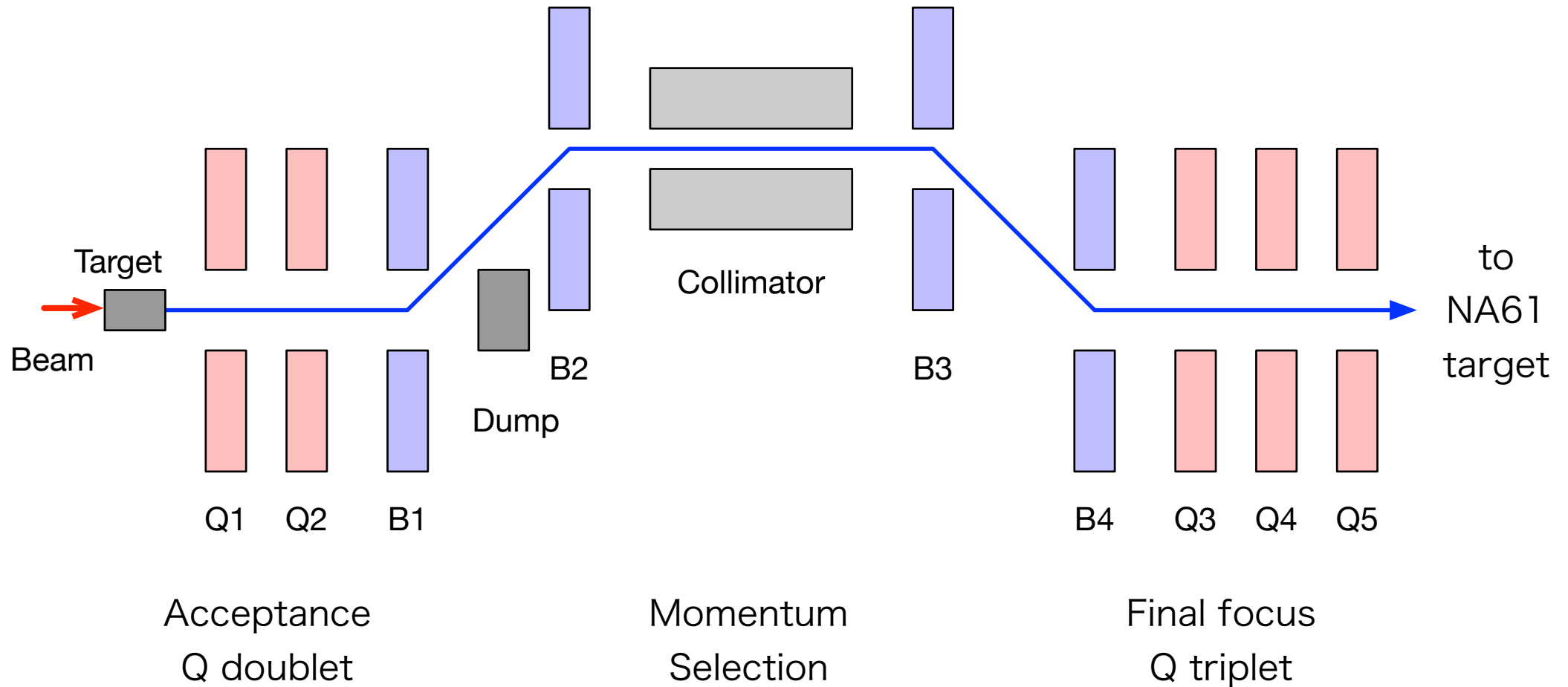
with discussion among N.Charitonidis, C.Mussolini and NA61 collaboration

Introduction

- N.Charitonidis, C.Mussolini are designing the low momentum beamline
- In this talk an initial idea of necessary beam instrumentation will be discussed
 - as a start point of discussion
 - need optimization

Current design of beamline

N.Charitonidis, C.A.Mussolini



Low-E beam momentum range : 1-15 GeV/c

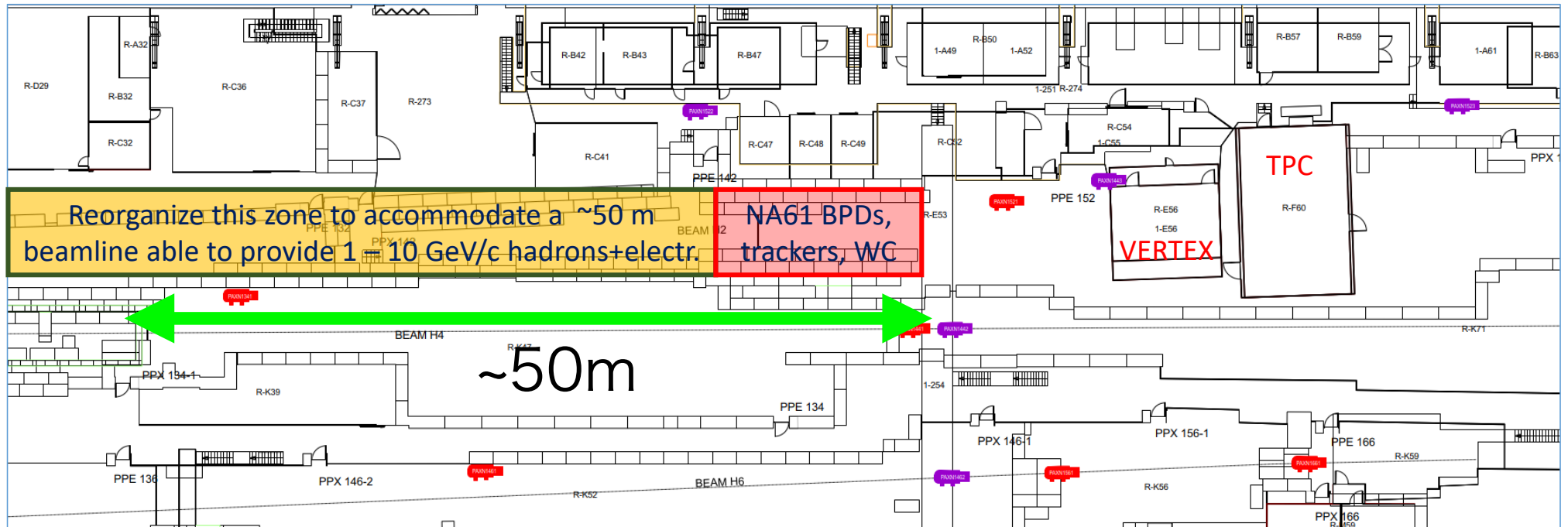
Particle composition : π , K, p, e, μ

Requirements on beam instrumentation

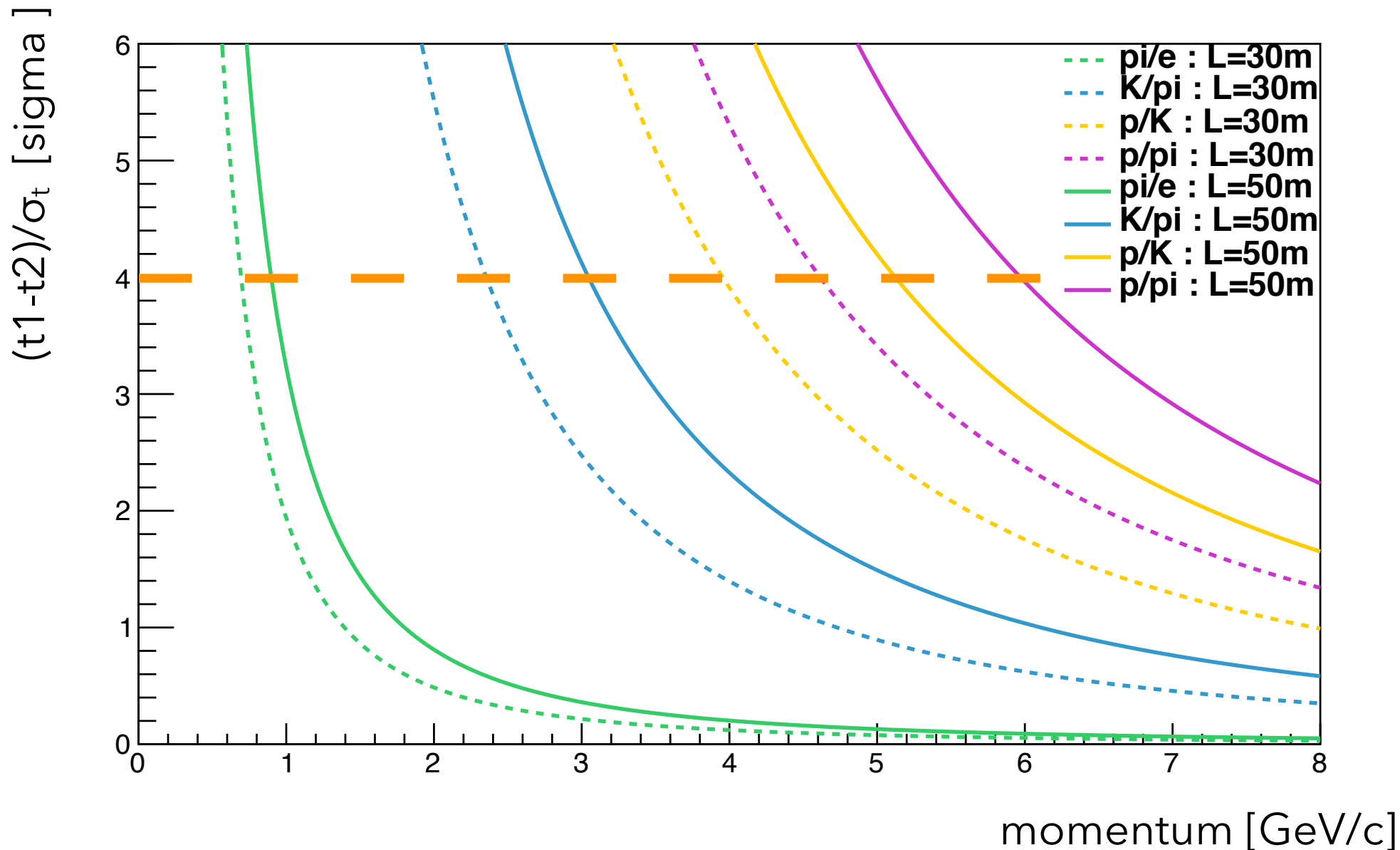
- Trigger
- Particle identification for π , K, p (also, e ?)
- Beam profile measurement for beam tuning
- Particle-by-particle momentum measurement

Time-of-flight, Trigger

- Possible inst. : plastic scintillation counter
- Distance between two TOF counters will be 30~50m



TOF discrimination power assuming 500ps resolution



Possible to discriminate $\pi/K/p$ up to $5\sim 6\text{GeV}/c$ if $L=50\text{m}$

Particle identification

- Gas Cherenkov counters (threshold type)
 - Similar to one used in H2-VLE
 - 2 m long chambers
 - assuming CO₂ gas filled
 - two counters with different pressures to cover a wide momentum range

$$P_{th} = \frac{m^2}{2(n_0 - 1)p^2}$$

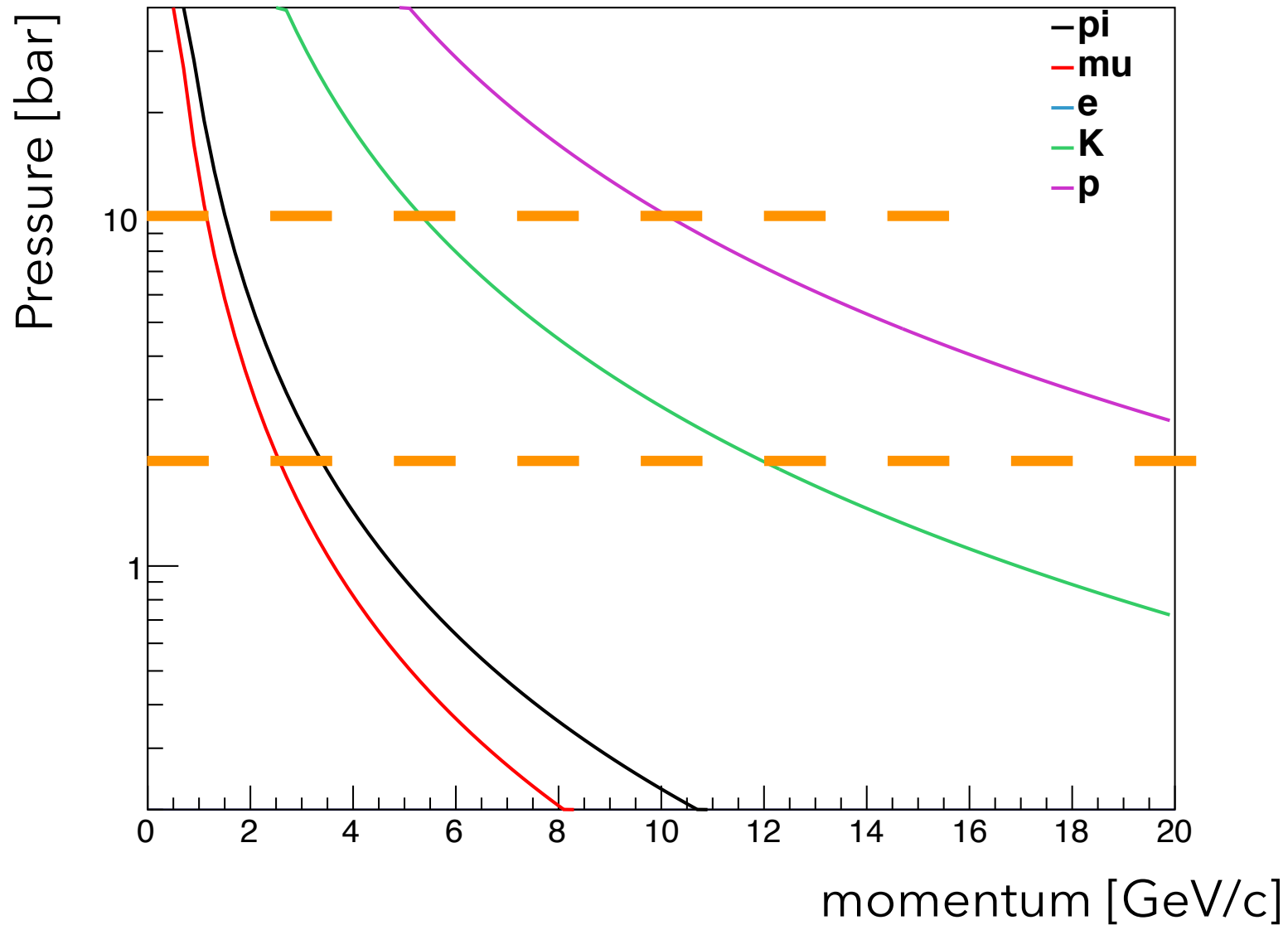
P_{th} : Chrenkov threshold pressure [bar]

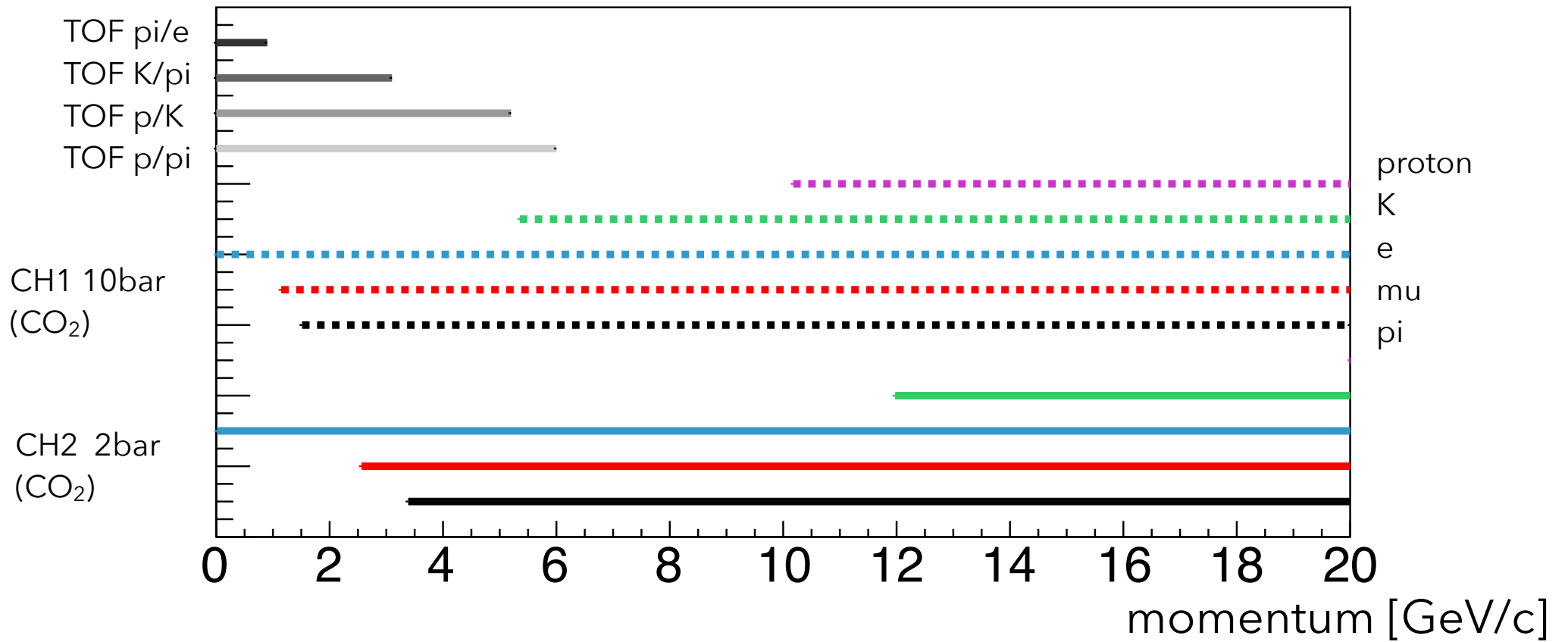
m : particle mass [GeV/c²]

p : particle momentum [GeV/c]

n_0 : refractive index at 1 bar

CO₂



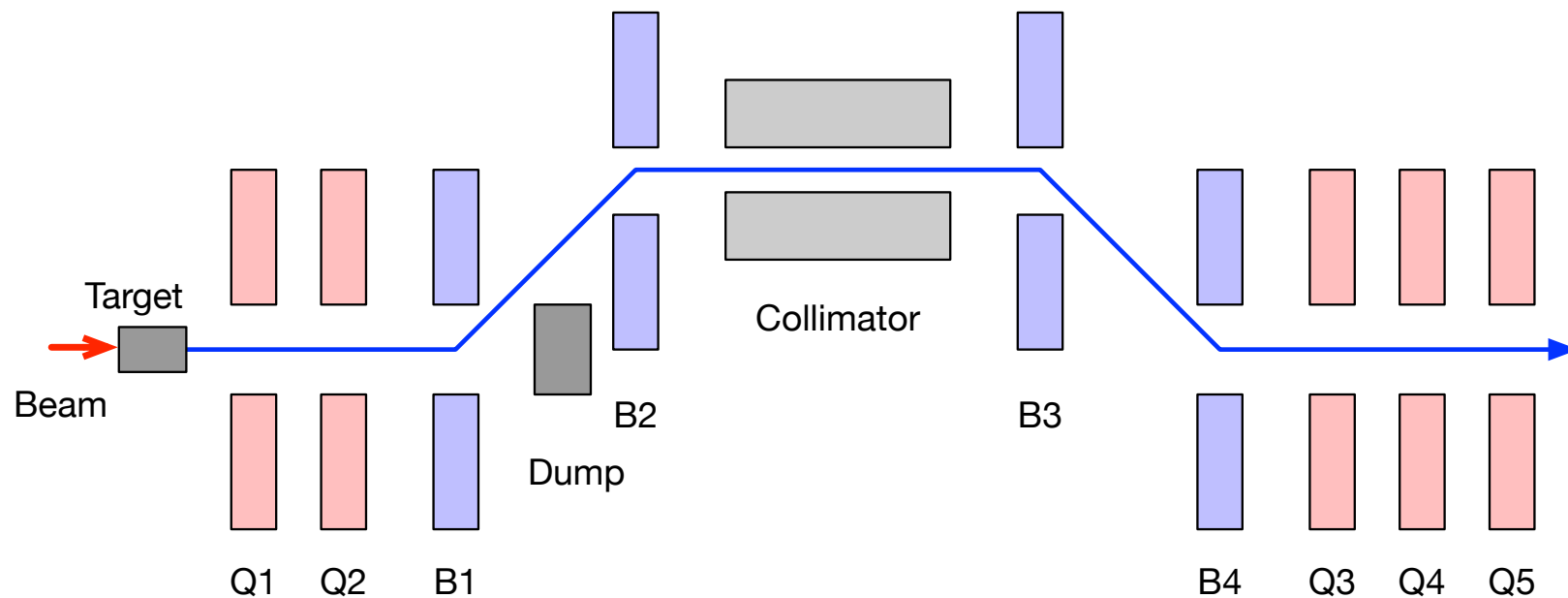


momentum	e	π	K	p
1	CH1 & CH2	TOF	TOF	TOF
3	CH1 & CH2	TOF & CH1	TOF	TOF
5	CH1 & CH2	CH1 & CH2	TOF	TOF
10	CH1 & CH2	CH1 & CH2	CH1 & $\overline{\text{CH2}}$	$\overline{\text{CH1}}$ & $\overline{\text{CH2}}$
15	CH1 & CH2	CH1 & CH2	CH1 & CH2	CH1 & $\overline{\text{CH2}}$

optimization is necessary

Momentum measurement

- Momentum spread after the collimator will be 5-10%
- It can be reduced with the momentum measurement by profile monitor
 - need to consider this necessity in term of requirements from physics targets
 - it is beneficial to keep the beam intensity



- Similar to the existing VLEs, momentum measurement utilizing beam profile monitor is possible solution

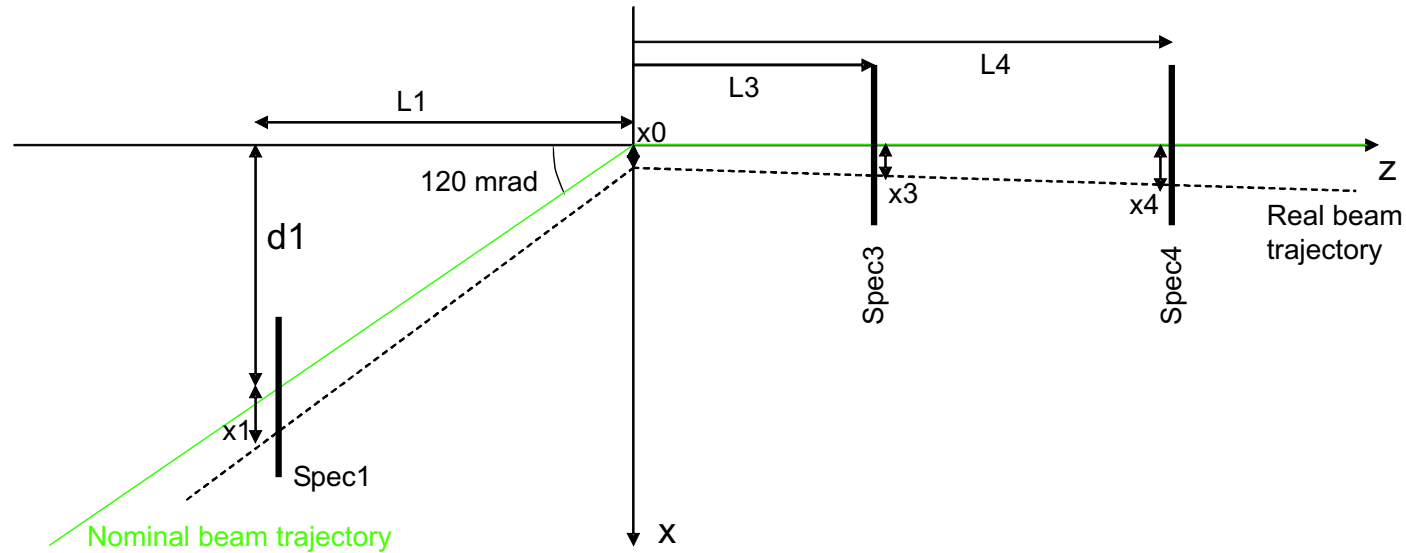


Figure 6: *Geometry of the VLE spectrometer for momentum analysis.*

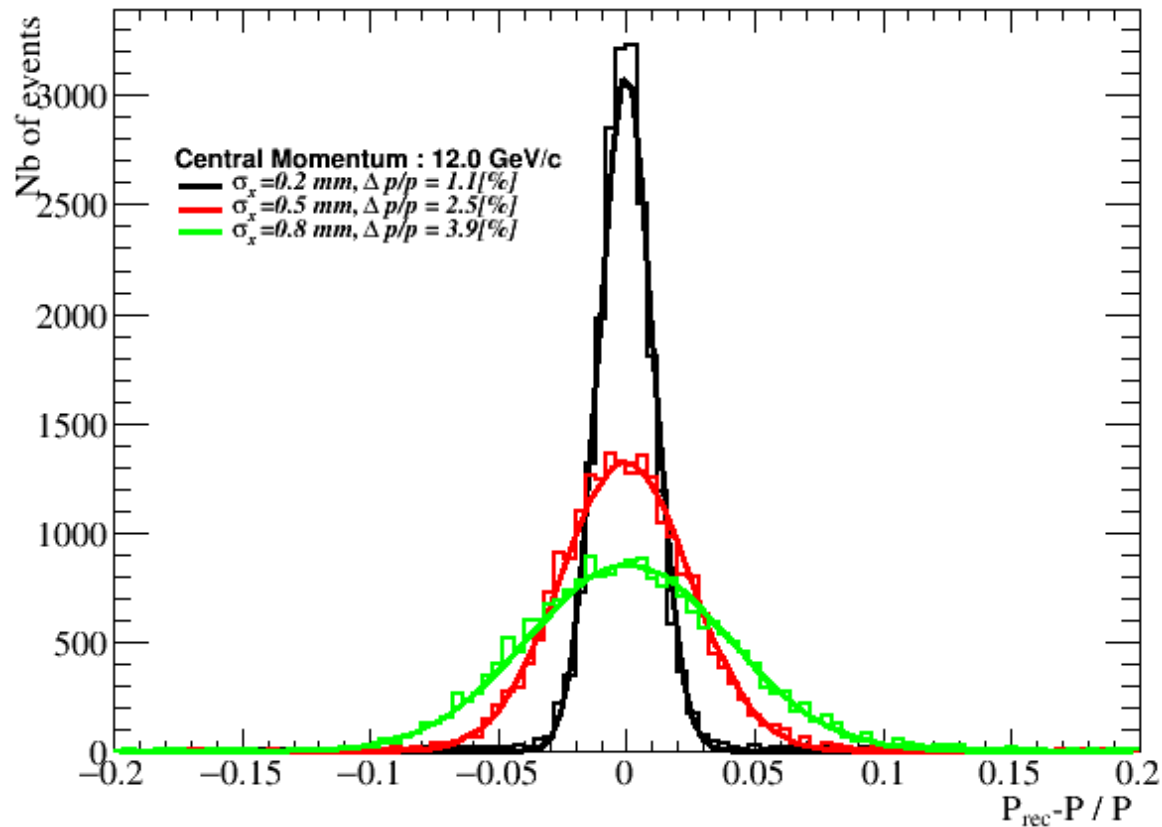
$$\cos \theta = \frac{L_1(L_4 - L_3) + (x_0 - d_1 - x_1)(x_4 - x_3)}{\sqrt{L_1^2 + (x_0 - d_1 - x_1)^2} \sqrt{(L_4 - L_3)^2 + (x_4 - x_3)^2}}$$

$$p [\text{GeV}/c] = \frac{299.79}{\theta [\text{mrad}]} \times \int B dl [\text{Tm}]$$

- Expected dp/p

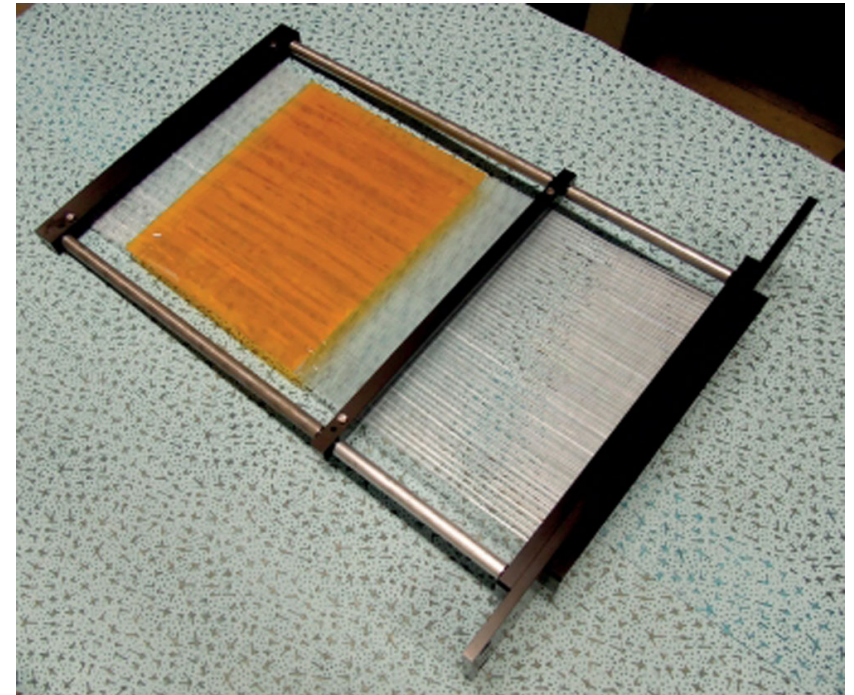
simulation results (H2-VLE)

w/o any effect of material in the beamline



$dp/p \sim 2\%$ is expected

profile monitor w/
scintillation fiber + SiPM

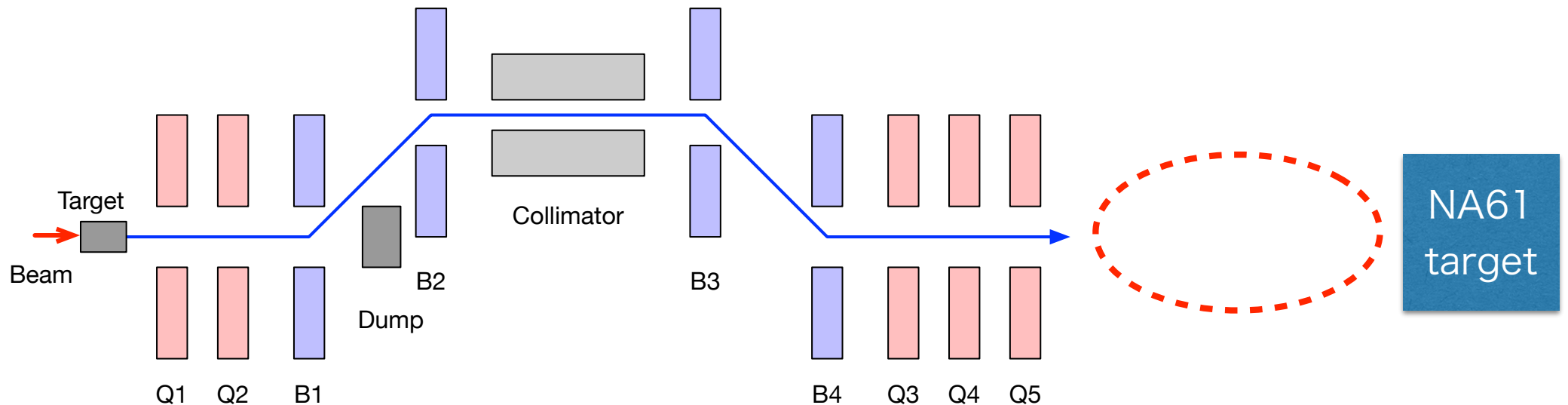


$\sigma \sim 0.3 \text{ mm}$

Similar simulation study including
the material effect is desired

Beam position detector

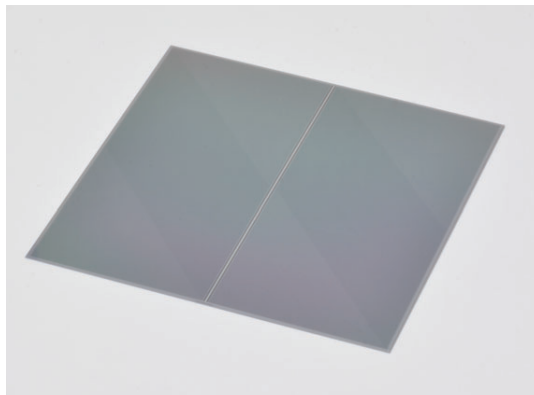
- Beam size will be increased for the low momentum beamline
- Plan to put a “wide-area” beam position detector (BPD) in the front of the NA61 target



Idea of “wide-area” BPD

- Silicon strip detector (SSD) which is commercially available at Japan
- Plan to proceed R&D of readout electronics etc. and make it ready for the low-E beamline construction
- primary option of the readout electronics is based on APV25+SRS (CERN RD51)

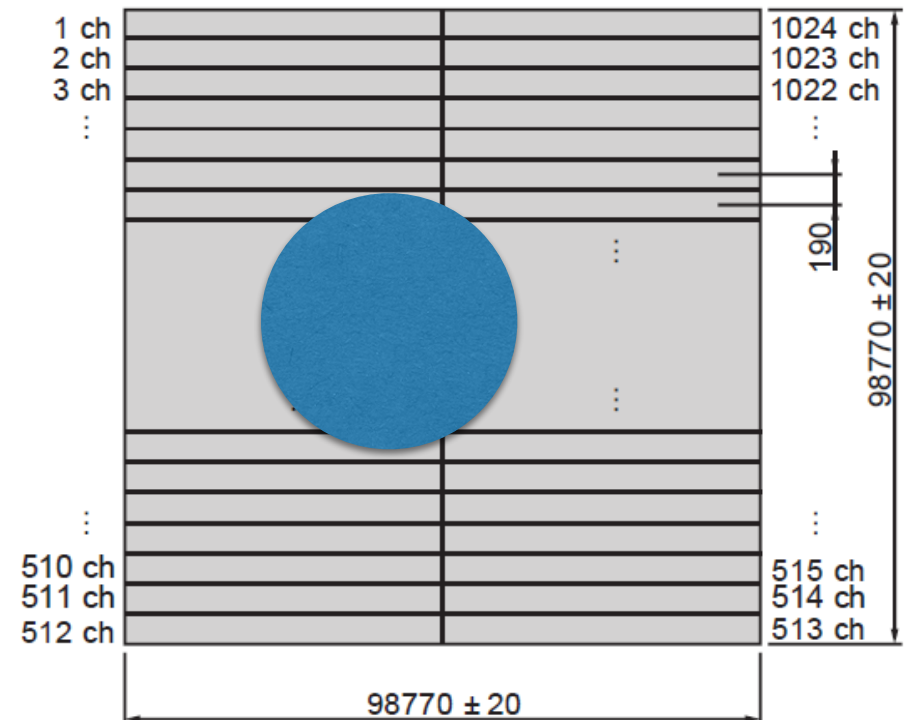
Si strip detector(Hamamatsu S13804)



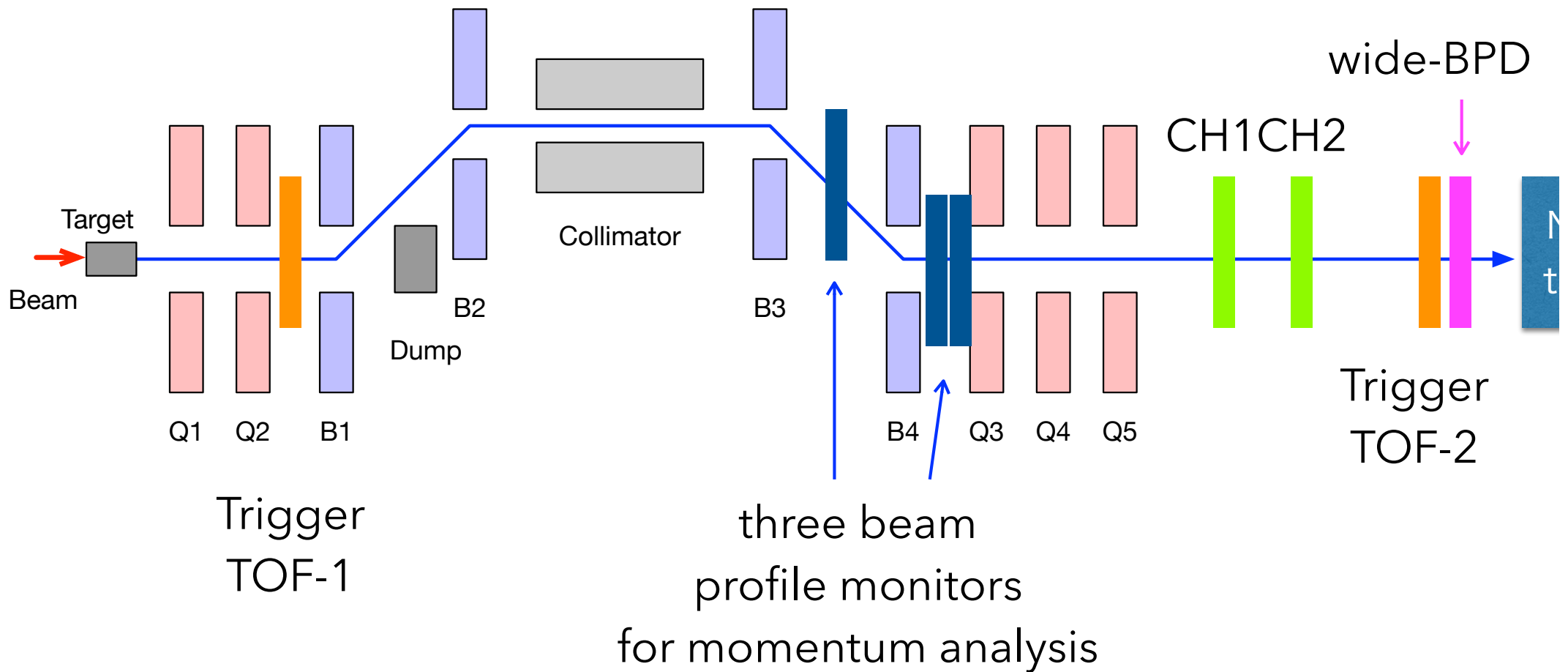
0.19mm pitch x 512ch x 2

■ Dimensional outline (unit: μm)

■ Entire device drawing



Summary of initial idea of beam instrumentation



Summary

- Initial idea of beam instrumentation is discussed
- Further study and optimization are necessary
 - PID method for $p > 5 \text{ GeV}/c$
 - Momentum measurement simulation including effect of materials in the beamline
- Detailed design of each instrumentation including choice of detector technology will be also performed